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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

10957 U.S. PTO
09/939332
08/24/01


Applicants: **ASKARINAM ET AL.**

Case: **5102/ETCH/DICP**

Serial No.: **not yet assigned** Filed: **Herewith**

Group Art Unit: **not yet assigned**

Examiner: **not yet assigned**

Title: **TOP GAS FEED LID FOR SEMICONDUCTOR PROCESSING CHAMBER**

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

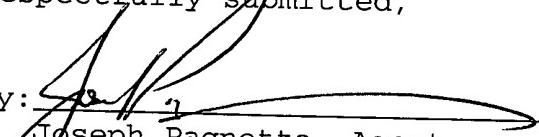
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Disclosure Statement under 37 CFR 1.56 and 1.98

Pursuant to 37 CFR 1.56, the documents (copies enclosed) listed on form PTO-1449, submitted herewith, are disclosed. Under rule 37 C.F.R. 1.98(a), the applicants submit that no specific comments are necessary for any of the cited foreign language publications having an enclosed English language translation or abstract.

Respectfully submitted,

July 25, 2001
Date

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